

Update on analysis of beam-test results

comparison v2 and v3 geometries

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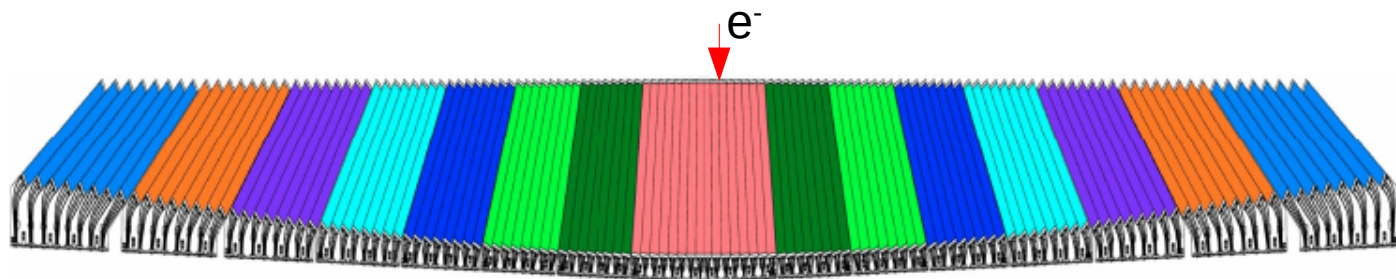
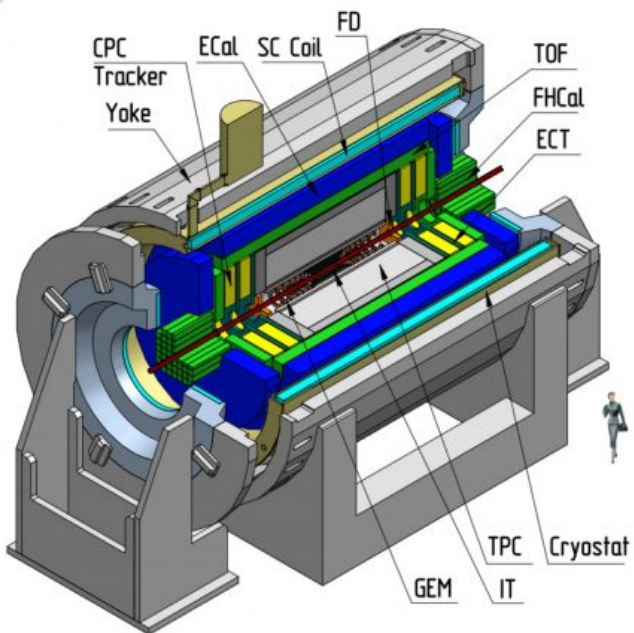
Data analyzed

- **Data**

- Kindly provided by Viacheslav Kulikov
- Electron beam 293 MeV
- Prototype 6*8 towers
- 14000 events

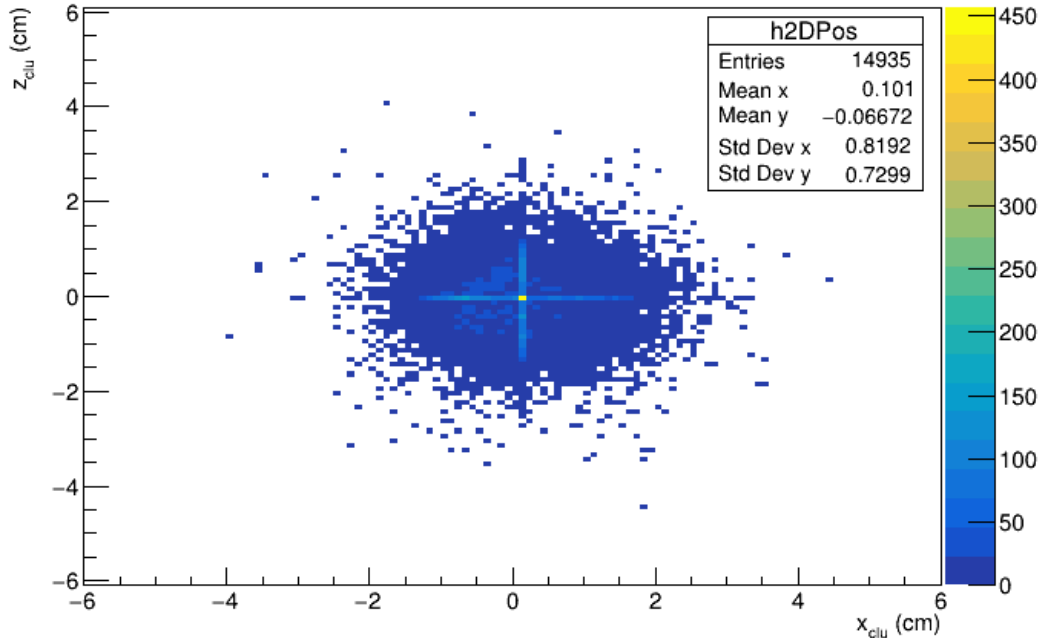
- **MC**

- Single electron simulation
- pt 290 MeV,
- direction $\eta=0$, $\phi=270^\circ$
- vertex just in front of center of EMCal tower
- $(7.5, -168., 7.5) \rightarrow$
 $(9., -168., 13.)$ cm
- Magnetic field off
- 10000 events



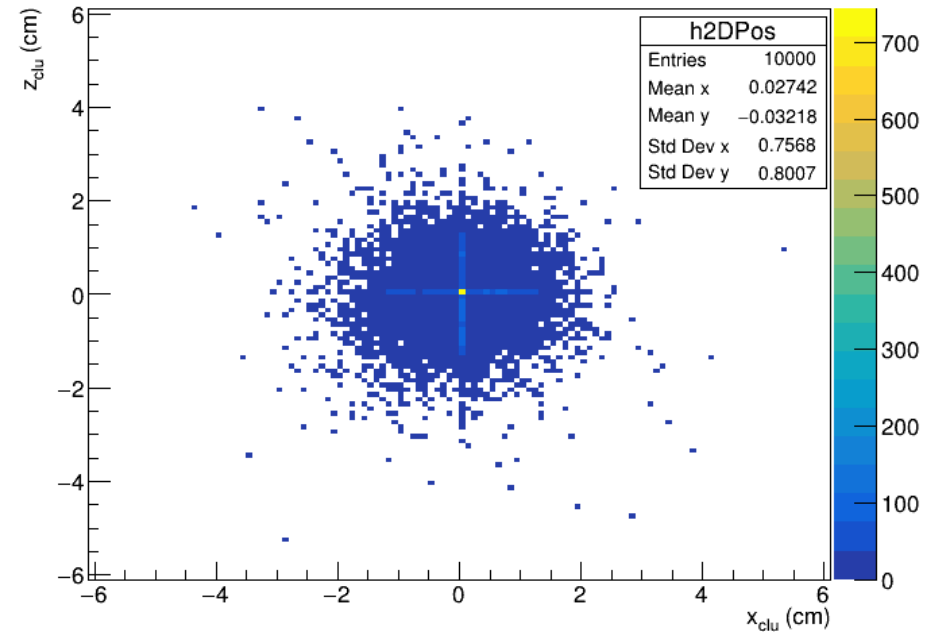
Choice of incidence position

Beam-test, position resolution



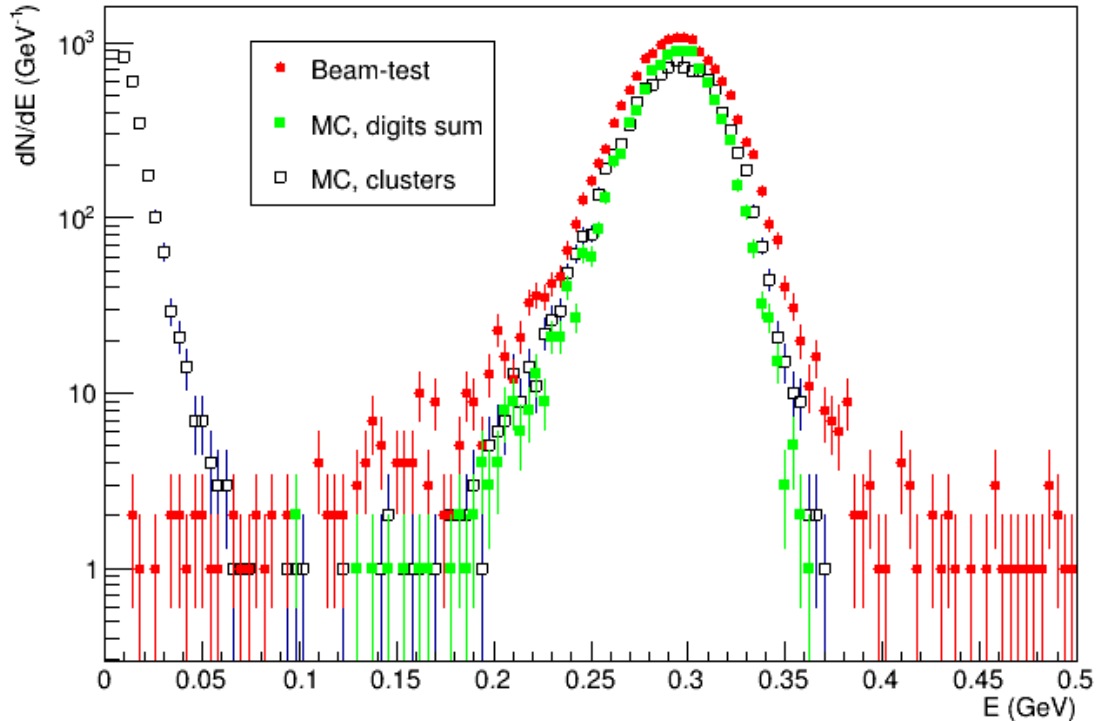
Cross appears when cluster multiplicity is low and corresponds to the center of tower.

MC simulations, geometry v3



Choose incident position to have same distribution: electron primary vertex: (9.5, -168., 13.0)

Comparison of energy resolution



Beam-test: sum of energies of all towers in event with $E_i > 100$ ADC (1.43 MeV)

$$\sigma = 22.6 \text{ MeV}^*$$

MC, digits sum: sum of all energy depositions in event above threshold (1.4 MeV)

$$\sigma = 18.1 \text{ MeV}^{**}$$

MC, clusters: standard clusterization applied. $E_{\min} = 1.5$ MeV, $E_{\text{seed}} = 10$ MeV, Digits with common edges added to cluster, common vertex not sufficient.

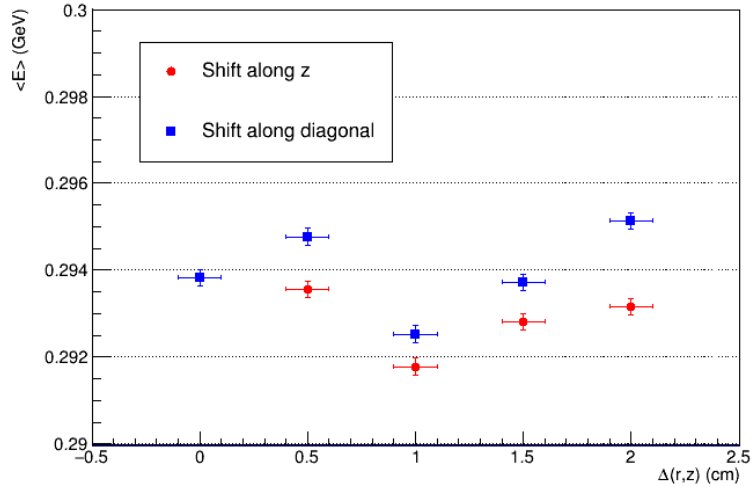
$$\sigma = 21.1 \text{ MeV}$$

*Fit with Gaus in range 0.22-0.35

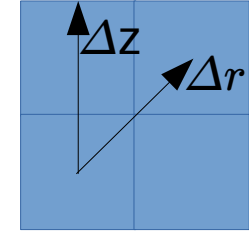
**MC calibration fixed to reproduce mean

Some electronic noise/digitization/... should be added to MC.
To check energy dependence of resolution, BT at several energies is necessary.

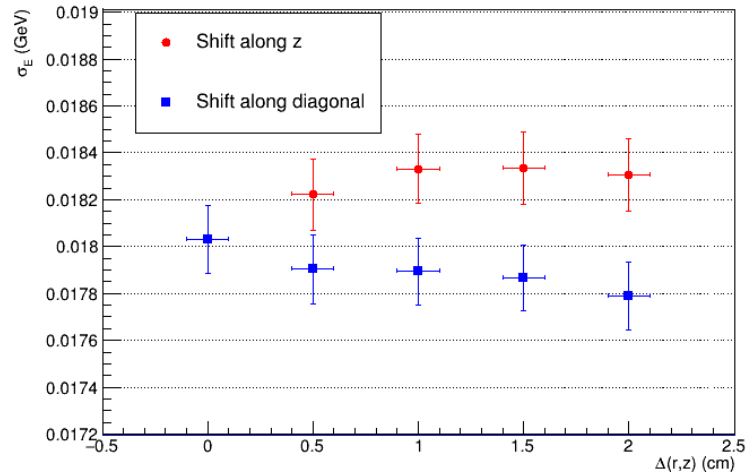
Energy resolution: dependence on hit position



Test mean energy and resolution vs. beam incidence position.

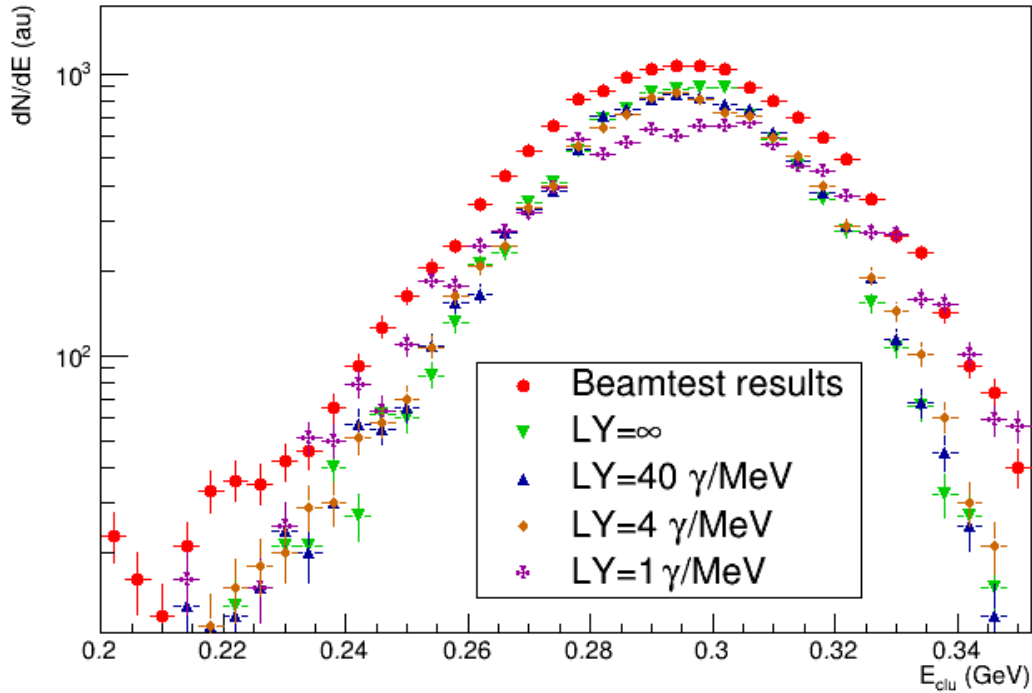


Zero: incidence into the center of tower, then moving along z axis and along diagonal.



Very minor dependence of mean energy (non-linearity) $\sim 0.5\%$
Small dependence of resolution $\sim 2\%$.

Energy resolution: varying light yield



Beam-test: sum of energies of all towers in event with $E_i > 100$ ADC (1.43 MeV)

$\sigma = 22.6$ MeV

MC, no simulation of light collection:

$\sigma = 18.1$ MeV

MC, simulation of light collection, 40 photons/MeV:

$\sigma = 18.7$ MeV

MC, LY on, 4 photons/MeV:

$\sigma = 19.5$ MeV

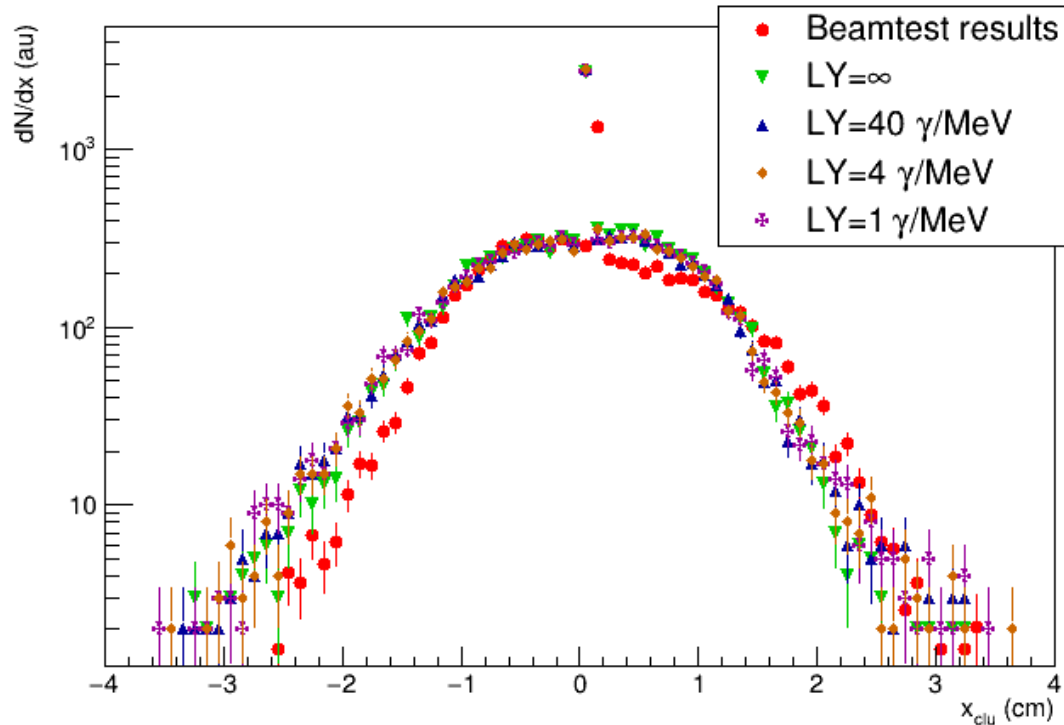
MC, LY on, 1 photon/MeV:

$\sigma = 24.4$ MeV

Position resolution

$$x = \frac{\sum x_i w_i}{\sum w_i}$$

$$w_i = \text{Max}(0, 3 + \log(E_i/E_{tot}))$$



Beam-test: use all towers in event with $E_i > 100$ ADC (1.43 MeV)

MC, digits sum: use all energy depositions in event above threshold (1.4 MeV)

Position resolutions are close, but shape in beam-test is different and asymmetric.

Conclusions

- Moving electron vertex in MC from the edge of EMC improved energy resolution
- Now energy resolution in MC without LY simulation and electronic noise is smaller than in beamtest
- Agreement can be reached both by adjusting LY and noise simulation, need another energy to fix
- Position resolution is similar, but because of asymmetry of beamtest results hard to make quantitative comparison.